

Sir:

PATENT Customer No. 22,852 Attorney Docket No. 07553.0023

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:	
Kiichi HAMA et al.	Group Art Unit: 1765
Application No.: 09/869,277	Examiner: UMEZ ERONINI, LYNETTE T
Filed: June 26, 2001)) Confirmation No.: 2374)
For: METHOD OF PLASMA PROCESSING	
Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450	

<u>COMMENTS ON STATEMENT OF REASONS FOR ALLOWANCE</u>

The Examiner made various characterizations and assertions about the claims and the related prior art in the statement of Reasons for Allowance, for example, on pages 3-5 of the Notice of Allowability mailed October 20, 2006. Although Applicants agree with the Examiner's ultimate conclusions that the claims are patentable because the prior art does not teach or suggest the claimed features set forth tin the claims, Applicants do not necessarily agree with each or every characterization and assertion contained in the Examiner's statement.

Furthermore, it is understood that the Examiner's characterizations were for purposes of referring to the prior art, and do not imply that the claims are limited by words not actually present in the claims. Therefore, unless expressly noted otherwise,

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Comments on Statement of Reasons for Allowance - January 22, 2007

Applicants decline to subscribe to any statement or characterization contained in the Notice of Allowability and its accompanying Reasons for Allowance.

Should the Examiner disagree with the Applicants' comments on the Reasons for Allowance, the Examiner is invited to contact the undersigned in order to resolve such disagreement.

If there is any additional fee due in connection with these Comments, please charge to our Deposit Account No. 06-0916.

Respectfully submitted,

FINNEGAN, HENDERSON, FARABOW, GARRETT & DUNNER, L.L.P.

Dated: January 22, 2007

By: Michael W. Kim

Reg. No. 51,880